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4/22/02  
Mousi

PATENT  
740819-474

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Masaaki NODA et al.

Serial No. 09/736,230

Filed: December 15, 2000

For: HIGH-VOLTAGE SEMICONDUCTOR  
DEVICE

) Group Art Unit: 2815

) Examiner: Joseph H. Nguyen

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being  
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Washington, D.C. 20231, on April 3, 2002

) Gwyn J. Cantrell  
Gwyn J. Cantrell

**REQUEST FOR RECONSIDERATION**

Honorable Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Examiner's non-final Office Action mailed December 13, 2001, the period for responding having been extended one (1) month, please consider the following request for reconsideration in connection with the above-identified application.

**REMARKS**

At the outset, the Examiner is thanked for the thorough review and consideration of the present application. The Examiner's non-final Office Action dated December 13, 2001 has been received and its contents carefully noted. Claims 1-12 are pending in the present application, of which claim 1 is independent.

**Claims 1-12 are Patentable over the Acknowledged Prior Art in view of Ronen;**

**The Examiner has Not Made a *Prima Facie* Case of Obviousness**

Claims 1-12 stand rejected under 35 U.S.C. § 103(a) as being unpatentable over the acknowledged prior art (APA) in view of Ronen, U.S. Patent No. 4,290,077 (Ronen). The